

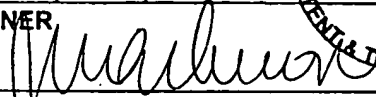


Form PTO-1449 (MODIFIED)		U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE		ATTY. DOCKET NO. 032026-0761		SERIAL NO. 10/802,259		
<b>INFORMATION DISCLOSURE CITATION</b> Submitted: August 3, 2004 (Use several sheets if necessary)				APPLICANT Robert H. Blick, et al.				
				FILING DATE 03/17/2004		GROUP ART UNIT 2811		
<b>U.S. PATENT DOCUMENTS</b>								
EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUB- CLASS	FILING DATE IF APPROPRIATE	
MH		6 589 717	7/8/03	Ghandehari, et al.				
<b>FOREIGN PATENT DOCUMENTS</b>								
	REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUB- CLASS	TRANSLATION	
							YES	NO
<b>OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)</b>								
MH		M.L. Roukes, "Nanoelectromechanical Systems Face the Future," Physics World 14, No. 25, February 2001.						
MH		D.V. Scheible, A. Erbe and R.H. Blick, "Tunable Coupled Nanomechanical Resonators for Single-Electron Transport," New J. Phys., 4, 2002, pp. 86.1-86.7.						
MH		N.V. Lavrik and P.G. Datskos, "Femtogram Mass Detection Using Photothermally Actuated Nanomechanical Resonators," Appl. Phys. Lett., Vol. 82, No. 16, 21 April 2003, pp. 2697-2699.						
MH		A. Erbe, C. Weiss, W. Zwerger and R.H. Blick, "Nanomechanical Resonator Shuttling Single Electrons at Radio Frequencies," Phys. Review Lett., Vol. 87, No. 9, 27 August 2001, pp. 096106-1 - 096106-4.						
MH		X.M.H. Huang, C.A. Zorman, M. Mehregany and M.L. Roukes, "Nanodevice Motion at Microwave Frequencies," Nature (London), Vol. 421, 30 January 2003, p. 496.						
MH		A.N. Cleland and M.L. Roukes, "Fabrication of High Frequency Nanometer Scale Mechanical Resonators from Bulk Si Crystals," Appl. Phys. Lett., Vol. 69, No. 18, 28 October 1996, pp. 2653-2655.						
MH		B. Ilic, D. Czaplewski and H.G. Craighead, "Mechanical Resonant Immunospecific Biological Detector," Appl. Phys. Lett., Vol. 77, No. 3, 17 July 2000, pp. 450-452.						

		M. Wendel, H. Lorenz and J.P. Kotthaus, "Sharpened Electron Beam Deposited Tips for High Resolution Atomic Force Microscope Lithography and Imaging," Appl. Phys. Lett., " Vol. 67, No. 25, 18 December 1995, pp. 3732-3734.
		C.T.-C. Nguyen, "Frequency-Selective MEMS for Miniaturized Low-Power Communication Devices," IEEE Trans. Microwave Theory Tech., Vol. 47, No. 8, August 1999, pp. 1486-1503.
EXAMINER 	DATE CONSIDERED 08/18/05	
<p>• EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include any copy of this form with next communication to applicant.</p>		

